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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi SERA et al.

Group Art Unit: 1762

Application No.: 10/630,861

Examiner: Unknown

Filed: July 31, 2003

Docket No.: 116741

For: METHOD OF MANUFACTURING RESIN INSULATING LAYER, SUBSTRATE FOR ELECTRIC OPTICAL APPARATUS, METHOD OF MANUFACTURING ELECTRIC OPTICAL APPARATUS, AND ELECTRIC OPTICAL APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

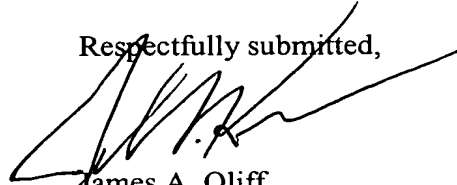
Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 3. An English language Abstract of the Japanese language reference is attached hereto.
- ☒ 4. A computer-generated English language translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy.

- ☒ 5. U.S. Patent Publication No. US 2001/0024247 A1 is the English-language counterpart of Korean Patent Application Publication No. KR A 2001-0092396 and JP A 2001-264810 is the Japanese-language counterpart of the Korean Reference.

Respectfully submitted,



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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 116741		APPLICATION NO. 10/630,861	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Hiroshi SERA et al.			
				FILING DATE July 31, 2003		GROUP 1762	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1	US 2001/0024247 A1	9/27/2001	Nakata			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	2	KR A 2001-0092396	10/24/2001	Korea			
	3	JP A 2001-264810 w/Abstract and Translation	9/26/2001	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: August 1, 2005